





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Sandhu et al.

Serial No.: 09/439,314

Filed: November 12, 1999

For: DEVICE FOR IN-SITU CLEANING OF AN  
INDUCTIVELY-COUPLED PLASMA CHAMBER

§ Group Art Unit: 1763  
§ Examiner: T. Dang  
§ Atty. Docket: 95-0392.02

COPY OF PAPERS  
ORIGINALLY FILED

RECEIVED  
MAR 15 2002  
TC 1700

112  
3/15/02  
M

TRANSMITTAL OF APPEAL BRIEF AND FEE AUTHORIZATION

Commissioner for Patents  
Washington, D.C. 20231

Certificate of Mailing (37 C.F.R. §1.8)  
I hereby certify that this correspondence is being  
deposited with the United States Postal Service as first  
class mail, postage prepaid, in an envelope addressed to:  
Commissioner for Patents, Washington, D.C. 20231

01/15/02   
Signature

Dear Sir:

Enclosed herewith is Applicants' Appeal Brief, submitted in triplicate. The Commissioner is authorized to charge the appropriate fee under 37 C.F.R. §1.17(c) of \$320.00, as well as any other required fee, to Micron Technology, Inc. Deposit Account No. 13-3092, Order No. 95-0392.02. This transmittal is being submitted in duplicate.

Respectfully submitted,



Charles B. Brantley II, Reg. No. 38,086  
Micron Technology, Inc.  
8000 S. Federal Way  
Mail Stop 525  
Boise, ID 83716-9632  
(208) 368-4557  
Attorney for Applicants